FIG. 1

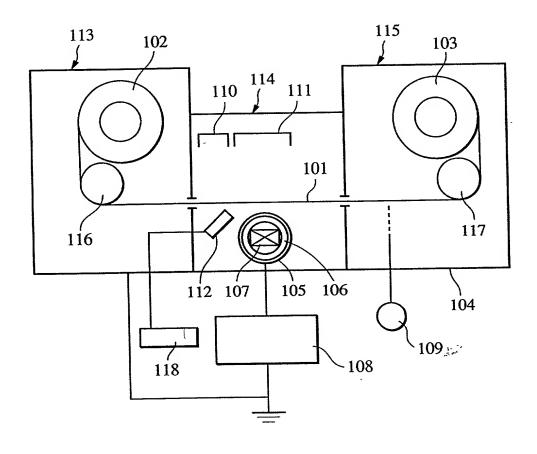


FIG. 2



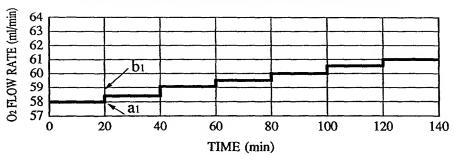


FIG. 3

## FILM THICKNESS CHANGE RESULTING BY INVENTIVE METHOD

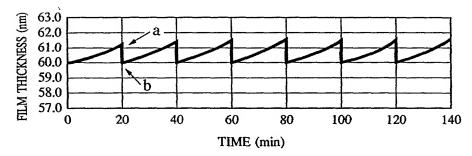


FIG. 4

## SHEET RESISTANCE CHANGE RESULTING BY INVENTIVE METHOD

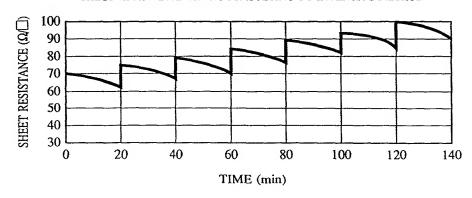


FIG. 5

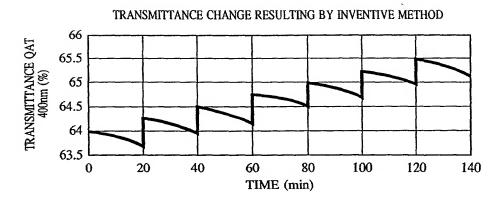


FIG. 6

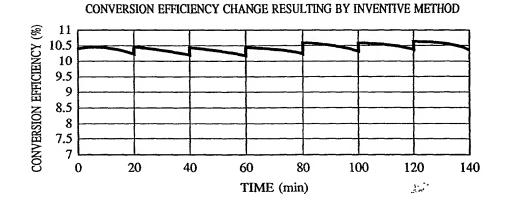


FIG. 7

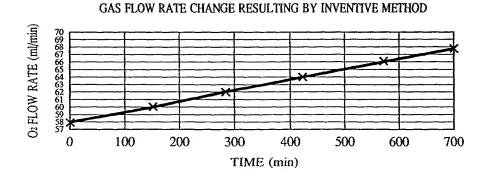


FIG. 8

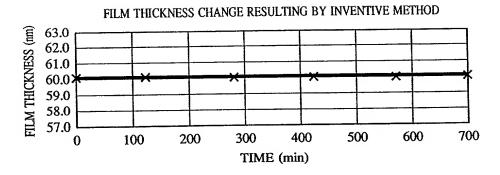


FIG. 9

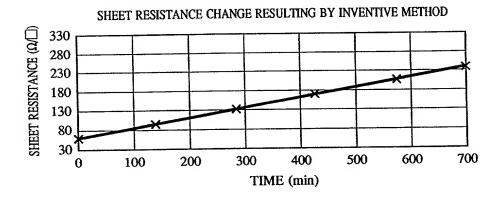


FIG. 10

أسالي

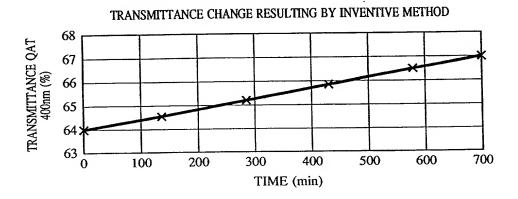


FIG. 11

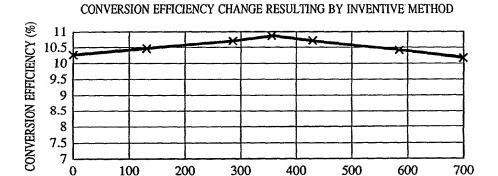


FIG. 12

TIME (min)

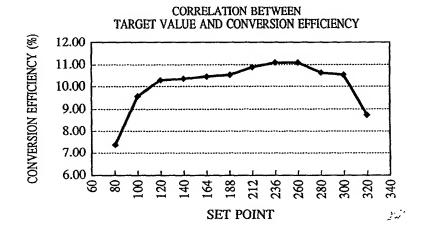


FIG. 13

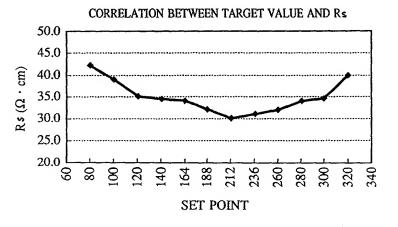


FIG. 14

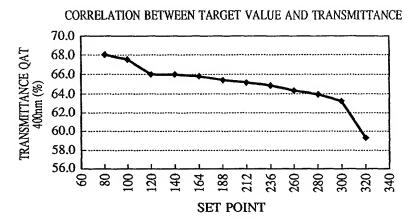


FIG. 15

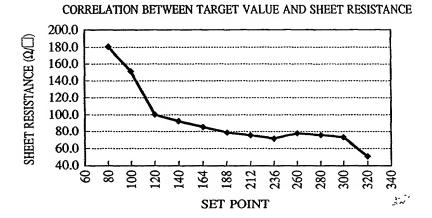


FIG. 16

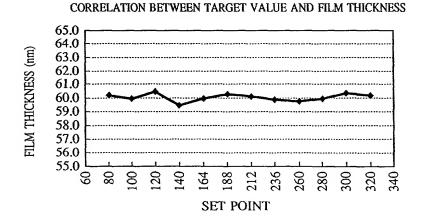


FIG. 17

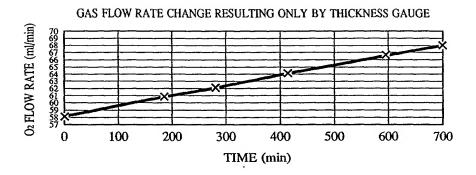


FIG. 18

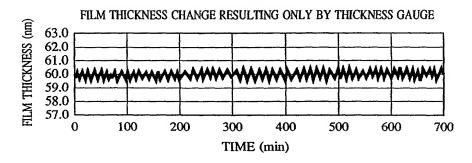


FIG. 19

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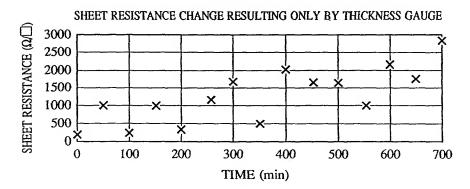
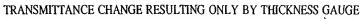


FIG. 20



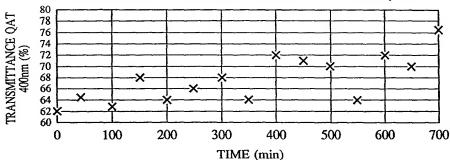


FIG. 21

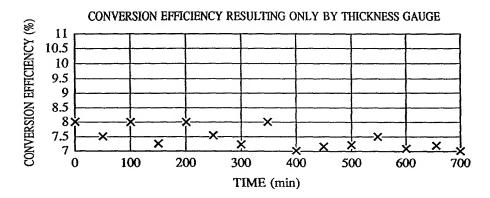


FIG. 22

## FILM THICKNESS CHANGE RESULTING ONLY BY PEM CONTROL IN REACTIVE SPUTIERING

 $y_{\mu'}$ 

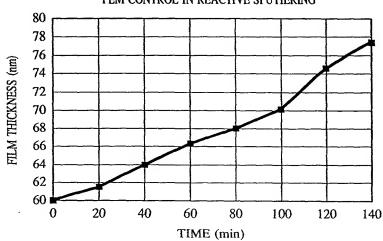
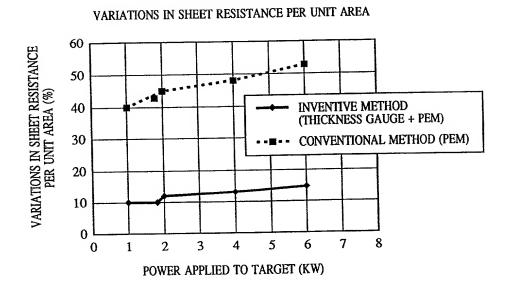


FIG. 23



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